

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Tatsuo ENAMI *et al.*

Serial No.: 09/518,639

Filed: March 3, 2000

For: ArF EXCIMER LASER DEVICE
SCANNING TYPE EXPOSURE DEVICE
AND ULTRAVIOLET LASER DEVICE

Submitted by Facsimile
Facsimile No. (703) 872-9319

Examiner: J. Zahn

Art Unit: 2828

RESPONSE AFTER FINAL UNDER 37 C.F.R. § 1.116

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 12, 2003

Dear Sir:

The following amendments and remarks are submitted in response to the Official action mailed February 12, 2003. The Official action set forth a three-month period for response, and a Petition for One-Month Extension of Time is being filed concurrently herewith, making this response due on or before June 12, 2003.

Please amend the above-identified application as set forth on the following pages. The following amendments are being made in accordance with the "Amendments in a Revised Format Now Permitted," published in the Official Gazette on February 25, 2003, volume 1267, number 4.

DO NOT ENTER
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7/3/03

#14/Amend D
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Q Focel
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Entered
7/23/03
FAX TO OFFICE
JUN 12 2003